

APPLICATION DATA SHEET

Inventor Information

Inventor One Given Name:: Jin-goo
Family Name:: Park
Name Suffix::
Postal Address Line One:: 402-1501, Hyundai2-cha Apt., Sa-dong,
Postal Address Line Two:: Kyunggi-do
City:: Ansan-city
State or Province::
Country:: Republic of Korea
Postal or Zip Code 425-170
Citizenship Country:: Korean

Inventor Two Given Name:: Dae-hong
Family Name:: EOM
Name Suffix::
Postal Address Line One:: 1473-301, Sa2-dong,
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City:: Ansan-city
State or Province::
Country:: Republic of Korea
Postal or Zip Code 425-825
Citizenship Country:: Korean

Inventor Three Given Name:: Jae-hwa
Family Name:: LEE
Name Suffix::
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Postal Address Line Two:: Kyunggi-do
City:: Ansan-city
State or Province::
Country:: Republic of Korea
Postal or Zip Code 425-170
Citizenship Country:: Korean

Inventor Four Given Name:: Neung-goo
Family Name:: YOON
Name Suffix::
Postal Address Line One:: 102-305, Hyundai Apt., Ichung-dong

Postal Address Line Two:: Pyongtaek Kyunggi-do
City::
State or Province::
Country:: Republic of Korea
Postal or Zip Code 459-824
Citizenship Country:: Korean

Correspondence Information

Correspondence Customer Number:: 6449

Application Information

Title Line One:: SEMICONDUCTOR WAFER CLEANING APPARATUS AND
Title Line Two:: CLEANING METHOD USING THE SAME
Total Drawing Sheets:: 1
Formal Drawings?:: YES
Application Type:: Utiliy
Docket Number:: 1751-297

Secrecy Order in Parent Appl?:: NO

Representative Information

Representative Customer Number:: 6449